

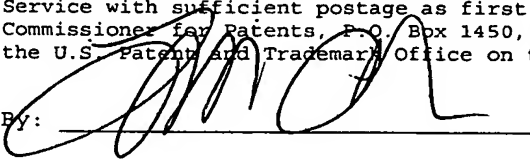


ITW

P2002,0637

CERTIFICATION OF MAILING OR FAX TRANSMISSION

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By: 

Date: November 9, 2004

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applic. No. : 10/631,384 Confirmation No. 9553
Applicant : Werner Plass et al.
Filed : July 31, 2003
TC/A.U. : 2826
Examiner : Ahmed N. Sefer
Title : Surface Emitting Semiconductor Laser Chip and
Method for Producing the Chip

Docket No. : P2002,0637
Customer No. : 24131

Hon. Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE

S i r :

In response to the Office action dated August 10, 2004, please consider the following remarks or arguments:

Remarks/Arguments begin on page 2 of this paper.